

Special Issue

Next-Generation Screen-Printed and Additive-Manufactured Electrochemical Platforms for Sensing

Message from the Guest Editor

Sensors based on screen-printing technology and additive manufacturing are used within the field of electroanalysis, where both approaches provide high reproducibility and sensitivities toward target analytes and are cost-effective. Both technologies are used to detect target analytes in tears, saliva, sweat, interstitial fluid of the skin, and human volatiles, as well as for environmental monitoring and food quality. We thus invite submissions to our Special Issue devoted to screen-printed and additive-manufactured sensors.

Guest Editor

Prof. Dr. Craig E. Banks

Faculty of Science and Engineering, Manchester Metropolitan University, Chester Street, Manchester M1 5GD, UK

Deadline for manuscript submissions

closed (20 October 2024)



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Sensors
Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
sensors@mdpi.com

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Message from the Editor-in-Chief

Sensors is a leading journal devoted to fast publication of the latest achievements of technological developments and scientific research in the huge area of physical, chemical and biochemical sensors, including remote sensing and sensor networks. Both experimental and theoretical papers are published, including all aspects of sensor design, technology, proof of concept and application. *Sensors* organizes Special Issues devoted to specific sensing areas and applications each year.

Editor-in-Chief

Prof. Dr. Vittorio M. N. Passaro

Department of Electrical and Information Engineering, Politecnico di Bari, Via Orabona 4, 70126 Bari, Italy

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